

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/722,186	KAMASAKI ET	AL.
Examiner	Art Unit	
Jinhee J. Lee	2174	

	SEARCHED				
Class	Subclass	Date	Examiner		
715	773	4/15/2007	LEE		
715	810,817	11/12/2007	LEE		
	818, 840				

INT	INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner			
715	as above	4/15/2007	LEE			

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
East text search attached	4/15/2007	LEE	
East search attached	11/12/2007	LEE	
NPL search, ACM digital library	11/13/2007	LEE	